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**AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 2625  
PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: 005329 USA M Y1/MASK/RT/OR  
(CA1124)

Shirley HEMAR, et al.

Appln. No.: 09/876,955

Group Art Unit: 2625

Confirmation No.: 4359

Examiner: John B. STREGE

Filed: June 7, 2001

For: ALTERNATING PHASE-SHIFT MASK INSPECTION METHOD AND APPARATUS

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 13, 2005, please amend the above-identified application as follows on the accompanying pages.

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